

9	Bereck ADJ1 compens\$?	USPAT; EPO; JPO; DERWENT IBM_TDB
0	Bereck AND reticle	USPAT; EPO; JPO; DERWENT IBM_TDB
11	babinet AND reticle	USPAT; EPO; JPO; DERWENT IBM_TDB
409	variable ADJ1 (retard\$?, waveplate)	USPAT; EPO; JPO; DERWENT IBM_TDB
2	(variable ADJ1 (retard\$?, waveplate)) AND reticle	USPAT; EPO; JPO; DERWENT IBM_TDB
1		USPAT
1		USPAT
86	waveplate WITH retarder	USPAT; EPO; JPO; DERWENT IBM_TDB
472	variable WITH retarder	USPAT; EPO; JPC DERWENT IBM_TDE
306	variable NEAR2 retarder	USPAT; EPO; JPC DERWENT IBM_TDE
0	(variable NEAR2 retarder) SAME reticle	USPAT; EPO; JPC DERWENT IBM_TDE
1	(variable NEAR2 retarder) AND reticle	USPAT; EPO; JPC DERWENT IBM_TDI
79	variable NEAR2 (wave-plate, (wave ADJ1 plate))	USPAT; EPO; JPC DERWENT IBM_TDI
2	(variable NEAR2 (wave-plate, (wave ADJ1 plate))) WITH reticle	USPAT; EPO; JPC DERWEI IBM_TD
2	(variable NEAR2 (wave-plate, (wave ADJ1 plate))) SAME reticle	USPAT; EPO; JPC DERWEI IBM_TD
2	(variable NEAR2 (wave-plate, (wave ADJ1 plate))) AND reticle	USPAT; EPO; JP DERWEI IBM_TD
13	(variable NEAR2 (wave-plate, (wave ADJ1 plate))) AND mask	USPAT; EPO; JP DERWE IBM_TC

4	(Kagaku NEAR2 Kogyo).in.	USPAT; EPO; JPO; DERWENT
74	(Kawakami NEAR2 Shojiro).in.	USPAT; EPO; JPO; DERWENT
5631	prism NEAR4 polari\$?	USPAT; EPO; JPO; DERWENT
789	Berek, Soleil	USPAT; EPO; JPO; DERWENT
0	(Berek, Soleil) SAME lithogr\$?	IBM_TDB USPAT; EPO; JPO; DERWENT
0	(Berek, Soleil) SAME lithogr\$?	IBM_TDB USPAT; EPO; JPO; DERWENT
15	(Berek, Soleil) AND lithogr\$?	IBM_TDB USPAT; EPO; JPO; DERWENT
3	((Berek, Soleil) AND lithogr\$?) AND reticle	IBM_TDB USPAT; EPO; JPO; DERWENT
0	"Berek's"	IBM_TDB USPAT; EPO; JPO; DERWENT
242	Berek ADJ1 compensa\$?	IBM_TDB USPAT; EPO; JPO; DERWENT
1	(Berek ADJ1 compensa\$?) SAME reticle	IBM_TDB USPAT; EPO; JPO; DERWENT
2	(Berek ADJ1 compensa\$?) AND reticle	IBM_TDB USPAT; EPO; JPO; DERWENT
60	Soleil-Babinet	IBM_TDB USPAT; EPO; JPO; DERWENT
3	Soleil-Babinet AND reticle	IBM_TDB USPAT; EPO; JPO; DERWENT
0	(Bereck ADJ1 compensator) AND reticle	IBM_TDB USPAT; EPO; JPO; DERWENT
9	Bereck ADJ1 compensator	IBM_TDB USPAT; EPO; JPC DERWENT

7665	beam ADJ1 expan\$?	USPAT; EPO; JPO; DERWENT IBM_TDB
73	(beam ADJ1 expan\$?) NEAR4 negative	USPAT; EPO; JPO; DERWENT IBM_TDB
163299	optical ADJ1 system	USPAT; EPO; JPO; DERWENT IBM_TDB
3435	(optical ADJ1 system) WITH reticle	USPAT; EPO; JPO; DERWENT IBM_TDB
18	((optical ADJ1 system) WITH reticle) SAME (waveplate, retard\$?)	USPAT; EPO; JPO; DERWENT IBM_TDB
2	5361268[pn]	USPAT; EPO; JPO; DERWENT IBM_TDB
1		USPAT
1		USPAT
1		USPAT
1		USPAT
1		USPAT
1		USPAT
1		USPAT
456	catadioptric WITH projection	USPAT; EPO; JPO; DERWENT IBM_TDB
157	(catadioptric WITH projection) SAME reticle	USPAT; EPO; JPO; DERWENT IBM_TDB
2	((catadioptric WITH projection) SAME reticle) SAME (retard\$?, waveplate)	USPAT; EPO; JPO; DERWENT IBM_TDB
173	(catadioptric WITH projection) SAME mask	USPAT; EPO; JPO; DERWENT IBM_TDB
0	((catadioptric WITH projection) SAME mask) SAME (retard\$?, waveplate)	USPAT; EPO; JPC; DERWENT IBM_TDB
0	((catadioptric WITH projection) SAME mask) SAME (retard\$?, wave-plate)	USPAT; EPO; JPC; DERWENT IBM_TDE
40	((catadioptric WITH projection) SAME mask) AND (retard\$?, wave)	USPAT; EPO; JPC; DERWENT IBM_TDE
950	microscope SAME reticle	USPAT; EPO; JPC; DERWENT IBM_TDE

0	(microscope SAME reticle) SAME waveplate	USPAT; EPO; JPO; DERWENT IBM_TDB
0	(microscope SAME reticle) SAME wave-plate	USPAT; EPO; JPO; DERWENT IBM_TDB
10	(microscope SAME reticle) AND (quarter-wave)	USPAT; EPO; JPO; DERWENT IBM_TDB
5	(microscope SAME reticle) AND waveplate	USPAT; EPO; JPO; DERWENT IBM_TDB
1	(microscope SAME reticle) AND halfwave	USPAT; EPO; JPO; DERWENT IBM_TDB
99855	align\$.ti.	USPAT; EPO; JPO; DERWENT IBM_TDB
11648	align\$.ti. AND (reticle OR mask)	USPAT; EPO; JPO; DERWENT IBM_TDB
47	(align\$.ti. AND (reticle OR mask)) AND (retarder OR waveplate OR wave-plate OR (wave ADJ1 plate))	USPAT; EPO; JPO; DERWENT IBM_TDB